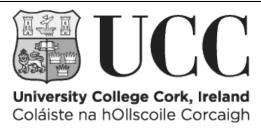


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Supporting Information: Electrodeposited thin film micro-thermoelectric coolers with extreme heat flux handling and microsecond time response

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Supplementary Tables

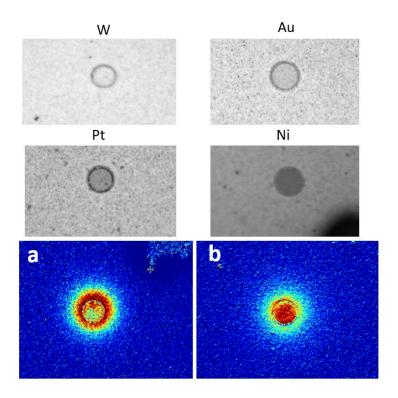
Table S1. Parameters used for Finite Element method simulation.

Material	Thermal Conductivity	Seebeck Coefficient	Electrical Conductivity
	WK ⁻¹ m ⁻¹	μVK ⁻¹	Sm ⁻¹
Au [1, 2]	200	6.5	45.6x10 ⁶
W [2, 3]	20	7.5	20x10 ⁶
SiN [4]	2	-	1.2x10 ⁻¹⁸
Bi ₂ Te ₃	As measured	As measured	As measured
SiO₂ [5]	1.4	-	1x10 ⁻¹⁸
Si [5]	130	-	5x10 ⁻⁴

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Supplemental Figures

Figure S1 Optical images showing various metal contacts and their diffusion into the TE layer.

Example of temperature maps from **a**) a bad metal contact and **b**) a W contact.

Initially several samples as in Fig.1a were made with a different metal replacing the W top contact layer. There was a noticeable degradation of the top contact with each as can be seen in Fig S.1 in the contrast between the circular pads. This is evidence of diffusion of the top layer metal layers into the Bi_2Te_3 beneath. Most of the pads could not be electrically contacted and those that could be, produced non ideal temperature maps as in Fig. S1.a. This ring of elevated temperature around the pad is evidence of current crowding and suggests that the top circular contact is physically receding beneath the SiN layer. Past a critical point there will be no circuit and the device will no longer work. Fig.S1.b shows an ideal temperature map typically produced by the W samples.

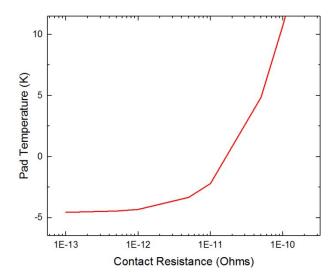


Figure S2. The effect of contact resistance on the top pad temperature.

FEM simulations were carried out with various contact resistances input at the top and bottom of the thermoelectric layer. Figure S2 shows the effect on the temperature rise for the top Au layer under a 200mA cooling current. The simulated results show that no net temperature differential would be allowed with contact resistance over $10^{-11}\,\Omega$. The increased contact resistance increases the joule heating at the interface thus lowering the possible achievable temperature difference.

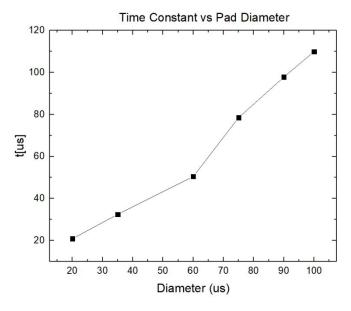


Figure S3. Time constant of cooling for various pad diameters.

FEM simulations showed that the cooling response times varied linearly on the diameter of the contact pad. As the contact pad diameters increased in size, the active region of the TE increased proportionally.

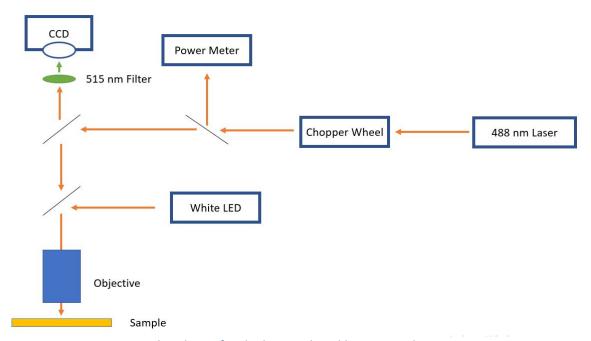


Figure S4 Optical pathway for the laser induced heating and CCD-TR setup.

An adaptation of the standard CCD-TR setup allows a laser to be used to induce a temperature rise on the top surface. The CCD camera is triggered to expose twice over the period of the chopped laser power such that two images are captured; one when the device is "hot" and the other "cold". The difference in intensity between the two images is the change in reflectivity due to thermoreflectance of the Au top surface from which the temperature can be extracted. The 515 nm filter is chosen for the peak sensitivity in golds thermoreflectance spectrum.

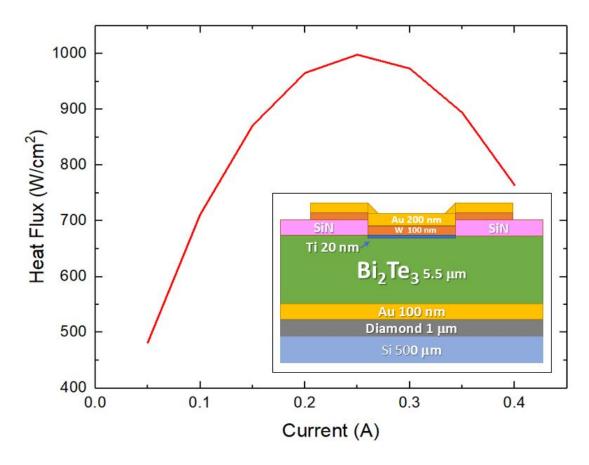


Figure S5 Cooling heat flux for various cooling currents with more ideal diamond substrate. Inset shows the diamond substitution layer instead of the silicon oxide layer.

The cooling heat flux of this device is limited due to the non-ideal design of this cooler with a low thermal conductivity layer of SiO₂. This essentially chokes the ability of the TE device to pump the heat downwards into the substrate at the hot side. If this layer was instead replaced by CVD grown diamond substrate with a thermal conductivity⁵¹ of 2200 Wm⁻¹K⁻¹ max theoretical heat flux of 1000 Wcm⁻² can be achieved.

S1 - http://www.iiviinfrared.com/Optical-Materials/thermal-grade-CVD.html

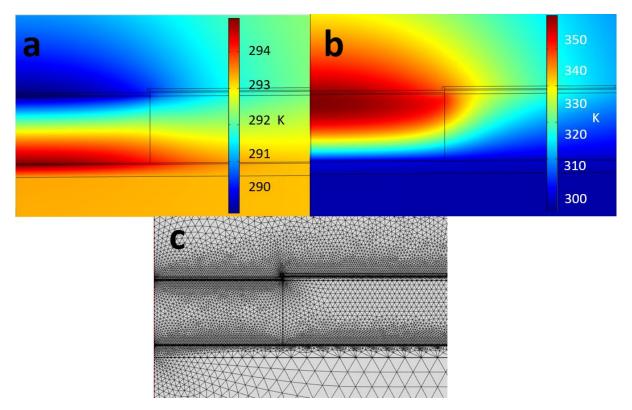


Figure S6 a) Example of cross section showing temperature gradient across device in cooling mode b) Example of cross section showing temperature gradient across device in cooling mode c) The same cross section showing the meshing size used in the COMSOL model.

A clear different is seen between the magnitude of the thermal gradients in Figure S6.a, S6.b which show a modelled crossection of the device as it is cooling the top surface and heating it respectively. This simulation does not take into account the Thomson effect or changes in thermal parameters with temperature. If the Thomson coefficient is taken to be negative then this would have the effect of reducing the magnitude of the top temperature of the TE device. A rough calculation of the relative magnitude of the thomson effect to the total heat generated by the TE material is 10% for a temperature difference of 50°C across the device induced by a 300mA current.

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